

FORM PTO-1449 (Modified) LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)			Attorney Docket No.: 18564-003000US Applicant: Nathan S. Lewis, et al. Filing Date: Herewith		Application No.: Unassigned Group: Unassigned	
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Reference Designation		U.S. PATENT DOCUMENTS				
Examiner Initial	Document No.	Date	Name	Class	Sub-class	Filing Date (If Appropriate)
<u>DKM</u>	AA	4,871,680	10/03/89	Barraud <i>et al.</i>	436	103
	AB	5,334,351	08/02/94	Heinze <i>et al.</i>	422	90
	AC	5,417,100	05/23/95	Miller <i>et al.</i>	73	31.02
<u>DKM</u>	AD	5,512,882	04/30/96	Stetter <i>et al.</i>	340	632
	AE					
	AF					
	AG					
	AH					
	AI					
	AJ					
	AK					
	AL					

FOREIGN PATENT DOCUMENTS						
	Document No.	Date	Country	Class	Sub-class	Translation (Yes/No)
<u>DKM</u>	AM	WO 9607901	03/14/96	PCT	G01N	33/00
	AN	EP 0161987	11/21/85	Europe (Abstract)	C07C	121/66
	AO	DE 3305683	08/23/84	Germany (Abstract)	G01N	27/12
	AP	DE 19509518	09/26/96	Germany (Abstract)	G01N	33/00
	AQ	DE 4241438	01/05/94	Germany	G01N	27/30 No
<u>DKM</u>	AR	EP 0251934	01/07/88	Europe	G01N	27/12 No

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)	
<u>DKM</u>	AS Lonergan, M.C., <i>et al.</i> , "Array-Based Vapor Sensing Using Chemically Sensitive, Polymer Composite Resistors" IEEE Aerospace Conference. 3:583-631 (1997)
<u>DKM</u>	AT Lonergan, M.C., <i>et al.</i> , "Array-Based Vapor Sensing Using Chemically Sensitive, Carbon Black-Polymer Resistors" Chem. Mater. 8(9):2298-2312 (1996)
	AU
	AV
	AW

EXAMINER <u>Wayne H. Harty</u>	DATE CONSIDERED <u>8/3/05</u>
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.